



500.41316X00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): T. KAJI, et al

Serial No.: 10/090,759

Filed: March 6, 2002

For: EMISSION SPECTROSCOPIC PROCESSING APPARATUS
AND PLASMA PROCESSING METHOD USING IT

Group: 1763

Examiner: P. Hassanzadeh

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SEP 15 2003
GROUP 1700

AMENDMENT

Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

September 11, 2003

Sir:

In response to the Office Action dated August 13, 2003, the following amendments and remarks are respectfully submitted in connection with the above-identified application, as listed below and as set forth on the following pages:

Amendment to the Title;

Amendments to the Claims; and

Remarks are included following the amendments.

TITLE OF THE INVENTION:

Please amend the title of the invention as follows:

EMISSION SPECTROSCOPIC PROCESSING APPARATUS AND PLASMA
PROCESSING METHOD USING IT